

FLOWSIC100 Flare-XT POWERFUL. RELIABLE. RUGGED

Gas flow measuring instruments



FLOWSIC100 Flare-XT: Powerful. Reliable. Rugged.

Increasing competition in the process industry means that operations and service work have to be optimized continuously. When it comes to flare gas measurement, the new FLOWSIC100 Flare-XT makes cutting costs so easy. State-of-the-art ultrasonic measuring technology provides maximum performance and robustness. As a result, the sensor continuously calculates accurate values even under extremely unstable conditions. In addition to this, thanks to i-diagnostics[™], the system monitors itself and informs the user in real time when maintenance is required, making fixed service intervals a thing of the past. We think that's intelligent.

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FLARE GAS MEASUREMENT REDEFINED: FLOWSIC100 Flare-XT

Dealing with difficult flare gas conditions, the requirements for measuring technology pose a challenge in the oil and gas and chemical and petrochemical industries:

- Gas velocities of 0 to 120 m/s or above
- · Rapid changes in the gas velocity
- Rapidly changing gas mixtures, such as natural gas, hydrogen, carbon dioxide, etc.
- Wet and dirty conditions

Ultrasonic flow meters continue to set the standard in flow measurement when it comes to dynamic range and accuracy. With FLOWSIC100 Flare-XT, SICK has developed a new generation of measuring device that works reliably and accurately even under extreme conditions. By combining two technologies in a single device, SICK is extending the typical ultrasonic measurement range with the unique ASC technology (active sound correlation). FLOWSIC100 Flare-XT is installed in next to no time and constantly monitors itself thanks to the i-diagnostics[™] function.

FLOWSIC100 Flare-XT at a glance:

- · Measurement availability even at high gas velocities and with changing gas mixtures
- · Proprietary measurement range extension for high flow velocities thanks to ASC technology (active sound correlation)
- Direct mass flow calculation without additional gas analyzers
- Intuitive FLOWgate[™] software for commissioning, operation and diagnostics
- I-diagnostics[™]: self-monitoring, self-verification and predictive maintenance
- · Individual application evaluation provides specific measurement performance





Flare gas measurement on offshore platforms ...

in chemical plants ...

and in the petrochemical industry.

SUPPORTING REGULATORY COMPLIANCE

Cutting-edge technology, designed to meet future environmental regulations

Environmental regulations are becoming stricter in many industries globally. Thanks to a combination of two individual measurement technologies, FLOWSIC100 Flare-XT sets new standards in the flare world. The measurement is continuously available in the event of emergency shutdowns, gas turbulence and high levels of background noise.

SICK sensor technology

Thanks to advanced signal processing, the hermetically sealed high-performance ultrasonic sensor allows a very high resolution of the signals and measures reliably and accurately even at very low gas velocities close to zero. FLOWSIC100 Flare-XT is also capable of performing measurements even under extreme conditions, with varying gas compositions and at high flow velocities. Developed specially for use with very high gas flows, measurement is also continuously available in the event of gas turbulence and emergency shutdown.

Precise measurement even at very low gas velocities close to zero

Hermetically sealed ultrasonic sensors made of titanium Above-average availability and resistance even under extreme measurement conditions

Patented, flow-optimized sensor design

Range extension using patented ASC technology

Ensuring measurement availability even at the highest gas velocities is one of the most important characteristics of a flare measurement system. Thanks to its innovative ASC technology (active sound correlation), FLOWSIC100 Flare-XT is now extending the previous maximum flow range by up to 30%. ASC correlates the gas velocity with application-specific noise generated under high flow conditions. The patented ASC technology thus allows even better coverage of possible flare gas events.



MOLAR MASS AND MASS FLOW CALCULATION

FLOWSIC100 Flare-XT directly calculates molar mass and outputs mass flow for typical hydrocarbon flare gases. Patented algorithms auto-tune the device - no parameterization or additional gas analyzer is required. Alternatively, gas chromatograph (GC) data can be input directly into the interface unit for maximum mass flow calculation accuracy.



Save money with nitrogen (N₂) subtraction

Flare gas lines are often purged with nitrogen to maintain a steady flow and prevent ingression of ambient air. A common problem in the industry is that nitrogen influences the molar mass calculation while CO_2 emissions only result from

Application consultation

Flare gas applications are one of the most challenging flow measurement tasks. Many different aspects, like gas matrix and gas condition, have an impact on ultrasonic measurement technology in general. Therefore SICK does not only hydrocarbon combustion. FLOWSIC100 Flare-XT can directly compensate for the nitrogen amount to correct the molar mass calculation.

extensively evaluate your individual application and select the right solution, but also comes up with a detailed measurability and uncertainty statement for FLOWSIC100 Flare-XT.





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THE RIGHT SOLUTION FOR EVERY CHALLENGE

With SICK, flare gas measurement is easy. Thanks to the broad FLOWSIC100 Flare-XT portfolio, there is a measurement solution even for very challenging applications. Reliable gas flow measurement is ensured at all times. The optional 2-path version achieves high accuracies and maximum measurement availability through a redundant layout. The probe version is suitable for compact, one-sided fitting, which minimizes the installation work required. A device retraction mechanism also allows sensors to be removed simply and quickly during operation. The interface unit processes incoming signals and stores data parameters, such as molecular weight, mass flow and gas volume, as well as standardized reference values. FLOWSIC100 Flare-XT can be commissioned and maintained intuitively from a laptop or tablet thanks to the FLOWgate[™] software.

Ultrasonic sensors	F1F-S	F1F-H	F1F-P	
	B. C. C.	No o o	I. B.	
Туре	Cross-duct measurement		Single-side probe	
Number of possible measuring paths		1-path / 2-path		
Pipe size 1-path	4" - 20"		12" - 72"	
Pipe size 2-path (not for FLOWSIC100 Flare-XT Transmitter execution)	12" - 20"	22" - 72"	18" - 72"	
Equipment protection level	Zone 1 - Intrinsic safety	Zone 1 - Flameproof	Zone 1 - Intrinsic safety	
Specialty	Suitable for low-temperature applications	-	Suitable for low-temperature applications	
	Powerful, hermetically sealed titanium sensors		ensors	
	-	For complex gas compositions and challenging application conditions	Single-side installation, only one side access required. One single weld-on nozzle.	

Interface Units - housing variants	Zone 2 Ex ec	Zone 1 Ex d	Zone 1 Ex de
	H SHCH		
Equipment protection level	Increased safety	Flameproof	Flameproof and increased safety enclosure
Material offshore suitability	No – steel sheet housing 1.4016	Yes – aluminum EN AC-42100 (copper content <0.05%)	Yes – aluminum EN AC-42100 (copper content <0.05%)
Suitable for tropical environment		Yes, as standard	
Cable entries	Up to 8 x M20 + 1 x M25 or 8 x ½" NPT + 1 x ¾" NPT		x ¾" NPT

POWERFUL. RELIABLE. RUGGED FLOWSIC100 Flare-XT

Product configurations	Flare Transmitter	Flare Instrument	Flare Meter
Blue parts: SICK scope of delivery Orange parts: Additional set of matching sensors (2 nd path) Gray parts: Optional parts	-		Reference meter
	/		11
Standard delivery scope	Sensors incl. interconnection cable		
	-	Interfa	ce unit
		Product and material certification	1
		-	Flare meter fully assembled in measured SICK spool piece
		-	Performance capability evaluation
Optional delivery scope	Performance capability evaluation		FLOW calibration
	-	Customized d	ocumentation
		Customer service training	
	Accessory spool piece for i	nstallation without welding	-
I/0	Modbus® RTU	Modbus®	RTU/TCP
		Foundatio	n Fieldbus
		Analog incl. HART /	' digital / frequency
Display	-	2	X
Counter / logbook / data archives	-	:	X
i-diagnostics™	-		x
Voltage supply	24 V DC	24 V DC / 115	5 V 230 V AC
Advantages	Lean measurement solution for basic requirements	Extended functionality	Extended functionality and low- est measurement uncertainty
Number of possible measuring paths	1-path	1-path ,	/ 2-path
Measurement uncertainty	*	**	***

Applicable installation equipment	Flare Transmitter	Flare Instrument	Flare Meter
Weld-on nozzles	,	X	-
Nozzle installation tool)	K	-
Ball valves)	K	X
Weather and sun protection		optional	·

FIT FOR THE SYSTEM ENVIRONMENTS OF TODAY AND TOMORROW

The powerful interface unit can be easily connected to a wide variety of systems and networks thanks to its numerous interfaces. Key parameters and measured value data such as volume flow, mass flow or molecular weight are reliably processed, evaluated and stored. In this respect, the internal memory makes it possible to permanently archive the data in a secure and structured manner.



SAVE COSTS WITH THE RIGHT ARCHITECTURE: Thanks to rugged, digital communication, the interface unit can be installed up to 1000 m away from the measurement point. There is therefore no longer any need for a local, flameproof and potentially expensive control unit.

Commissioning, parameterization and monitoring – easier than ever before with FLOWgate™

The intuitive software FLOWgate[™] provides various solution assistants that support installation, monitoring and service. Thanks to the interface unit, instrument and meter configurations benefit from i-diagnostics[™] functionality in FLOWgate[™].

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All relevant measured values are displayed on the overview page

This permits quick and uncomplicated system analysis. By means of graphically prepared data and trend analyses, measurement processes can be easily traced, status changes can be identified early on and reports can be compiled.



Clear display of measured values and diagnostic data

From time-based to condition-based maintenance thanks to interface unit with i-diagnostics™



Predictive maintenance: flexible service intervals

The system permanently monitors parameters such as the "automatic gain control" or the "signal-to-noise ratio". Based on existing data and the development of measured values, i-diagnostics™ provides reliable predictions and maintenance recommendations. System-critical operating conditions are thus avoided – and unplanned downtimes are prevented.



One-click verification report: instant device verification

On request, the system checks itself and logs its current status. Users thus have the uncomplicated option of creating verification documents to prove that all emission requirements have been met.



Automatic self-diagnosis

i-diagnostics[™] links software and firmware intelligently: the self-monitoring system provides valuable data on the device status and shows all changes. Application errors are immediately detected and documented – there is no need for lengthy troubleshooting.

Retrofit solution for flare gas measuring devices

With the revamping solutions from SICK, converting an ultrasonic measurement for flare gas becomes child's play. You keep your nozzles, your shut-off valves, your p/T transmitters and even your cabling: retrofitting your flare gas system with modern flare gas measurement technology from SICK has never been easier. Since you can continue to use the existing nozzles and shut-off valves, no hot tapping or pressure reduction on the flare gas line is required. Both cross-duct and single-sided installations with measurement angles of 45°, 60°, 75° and 90° are easily exchangeable.



Retrofit solutions for existing measurement systems

In use all over the world. Based on the application experience of a global fleet of thousands of FLOWSIC100 Flare installations, the reinvented FLOWSIC100 Flare-XT is applicable for flare gas measurements worldwide. The requirements of various directives and standards are observed.

(ISO 17089-2, EPA 40 CFR part 98, 30 CFR part 250, 40 CFR Part 60 Subpart Ja, MACT RSR 63.670, API 22.3, EU ETS etc.) Explosion protection requirements: ATEX, CSA and IECEx and other local certifications.

FLARE GAS MEASUREMENT REDEFINED: FLOWSIC100 Flare-XT



Product description

The gas flow measuring device FLOWSIC100 Flare-XT features a unique flow-optimized sensor design, which allows reliable measurements at high gas velocities and changing gas compositions. The rugged design and patented ASC-technology ensure improved measurement availability even under the most adverse conditions.

At a glance

- Measurement availability under all operating conditions, at high gas velocities and with changing gas compositions
- Individual application evaluation

Your benefit

- Comply with environmental regulations
- Maximum plant availability
- Ultrasonic sensors, interface unit, Spool Piece from a single source as well as globally available services
- Compatible with current and future communication architectures

FLOWSIC100 Flare-XT observes several applicable standards and is suitable for use in new and existing plants. Measurement and diagnostic data are easily visualized by FLOWgate[™] software. Thanks to the intelligent diagnostic function i-diagnostics[™] the system checks itself and reports independently if maintenance is required.

- i-diagnostics[™] for self monitoring, easy verification and condition-based maintenance of the system
- Retrofit solutions for existing measurement systems
- Independent maintenance through verification on demand and support by SICK when required
- Easy replacement of existing measurement systems, with suitable retrofit or upgrade solutions available

Fields of application

- Flare gas measurement for the production and processing of natural gas and associated petroleum gases (APG) in oil production
- Flare gas measurement in chemical and petrochemical plants as well as refineries
- Measurement of LNG boil-off gas down to -196°C
- Plants onshore and offshore
- Flare gas containing H₂S, CO₂ and H₂

→ www.sick.com/FLOWSIC100_Flare-XT

For more information, simply visit the above link to obtain direct access to technical data, CAD design models, operating instructions, software, application examples, and much more



Detailed technical data

The exact device specifications and performance data of the product may deviate from the information provided here, and depend on the application in which the product is being used and the relevant customer specifications. Please contact your local SICK representative to inquire about FLOWSIC100 Flare-XT performance for your application.

System FLOWSIC100 Flare-XT

Measured values		Mass flow rate, volumetric flow s. c. (standard condition), volumetric flow a. c. (actual condition), molecular weight, gas volume and mass, gas velocity, gas temperature, sound velocity
Number of measuring	paths	Single path, Dual path
Nominal pipe size	1-path measurement 2-path measurement	4 " 72 " 12 " 72 " Other nominal sizes on request
Measurement principl	e	Ultrasonic transit time difference measurement, ASC-technology (active sound correlation)
Measuring medium		Typical flare gas
Measuring ranges 1		0.03 m/s 120 m/s
Measuring span ¹		Up to 4000:1
Repeatability		(acc to ISO 5725-1; JCGM 200:2012): < 0.5 % of the measured value in the range \geq 1 m/s
Resolution		(acc. to JCGM 200:2012): + 0.001 m/s
·	Volumetric flow a. c. Mass flow rate	1 % 5 % Related to the measured value with ultrasonic technology (in the range ≥ 0.3 m/s to measuring range end value) 0.5 % 1.5 % with Spool Piece and flow calibration Related to the measured value with ultrasonic technology (in the range ≥ 1 m/s to calibration range end value) ⁴ 2 % 5.5 % Related to the measured value with ultrasonic technology (in the range ≥ 0.3 m/s to measuring range end value) 1.5 % 2 % with Spool Piece and flow calibration Related to the measured value with ultrasonic technology (in the range ≥ 1 m/s to calibration range end value)
Uncertainty of measur ASC-technology ^{1,2,5}	rement Volumetric flow a. c.	1%8%
Ambient humidity		≤ 95 % Relative humidity
Conformities		ATEX: 2014/34/EU EMC: 2014/30/EU PED: 2014/68/EU
Electrical safety		IEC 61010-1
Footnote		 ¹ Depending on the application conditions such as gas composition, process temperature, type of device, pipe diameter, etc. For mass flow additionally selection and parameterization of the conversion algorithm as well as uncertainty of the pressure and temperature sensors. To be evaluated by SICK. ² With fully developed turbulent flow profile. Typically 20D straight upstream and 5D straight downstream piping is required. ³ Below a specific threshold Reynolds number, only run time effects and uncertainties of geometry, excluding contributions from the flow profile are considered. ⁴ Depending on the capabilities of the selected flow lab. ⁵ Additional uncertainty. In the range 100 % 130 % of the last gas velocity measurable with ultrasonic transit time difference measurement

General technical information for ultrasonic sensors

Ambient temperature Sensors, ignition group IIC T4 Sensors, ignition group IIC T4 Sensors, ignition group IIC T6 Sensors, ignition group IIC T6	-40 °C +70 °C -50 °C +70 °C (Optional) -40 °C +55 °C -50 °C +55 °C (Optional)
Storage temperature	-40 °C +70 °C -50 °C +70 °C (Optional)
Enclosure rating	IP66 / IP67
Dimensions (W x H x D)	For details see dimensional drawings

F1F-S

Operating pressure ¹	
CL150 device flange	20 bar(g)
PN25 device flange (optional)	20 bar(g)
CL300 device flange (optional)	20 bar(g)
	¹ Temperature dependent. For details, see section Application ranges.
Ex-approvals	
IECEx	Ex db [ia Ga] IIA T4 Ga/Gb
	Ex db [la Ga] IIB T4 Ga/Gb
	Ex db [ia Ga] IIC T6 Ga/Gb
	Ex ia IIC T6 Ga
ATEX	II 1/2G Ex db [ia Ga] IIA T4 Ga/Gb
	II 1/2G Ex db [Ia Ga] IIB T4 Ga/Gb
	II 1/2G Ex db [ia Ga] IIC T6 Ga/Gb
	II 1G Ex ia IIC T6 Ga
NEC/CEC (US/CA)	Class I, Division 1, Group D, T4;
	Class I, Zone 1, Ex/AEx d[ia] IIA, T4;
	Class I, Division 2, Group D, T4;
	Class I, Zone 2, Ex/AEx nA[ia] IIA, T4
	Class I, Division 1, Groups C and D, T4;
	Class I, Zone 1, Ex/AEx d[ia] IIB, T4;
	Class I, Division 2, Groups C and D, T4;
	Class I, Zone 2, Ex/AEx nA[ia] IIB, T4
	Class I, Division 1, Groups B, C and D, T4;
	Class I, Zone 1, Ex/AEx d[ia] IIB + H2, T4;
	Class I, Division 2, Groups A, B, C and D, T4;
	Class I, Zone 2, Ex/AEx nA[ia] IIC, T4
Gas temperature	-196 °C +280 °C
Weight	≤ 12 kg (pair of ultrasonic sensors)

F1F-H

Operating pressure ¹	
CL150 device flange	ATEX/IECEx: 20 bar(g)
	CSA: 16 bar(g)
PN25 device flange (optional)	ATEX/IECEx: 20 bar(g)
	CSA: 16 bar(g)
CL300 device flange (optional)	ATEX/IECEx: 20 bar(g)
	CSA: 16 bar(g)
	¹ Temperature dependent. For details, see section Application ranges.
Ex-approvals	
IECEx	Ex db IIC T6 Gb
ATEX	II 2G Ex db IIC T6 Gb
NEC/CEC (US/CA)	Class I, Division 1, Groups B, C and D, T4;
	Class I, Zone 1, Ex/AEx d IIB + H2, T4;
	Class I, Division 2, Groups A, B, C and D, T4;
	Class I, Zone 2, Ex/AEx nA IIC, T4
Gas temperature	-70 °C +280 °C
Weight	≤ 14 kg (pair of ultrasonic sensors)

F1F-P

CL150 device flange ATEX/IECE: 20 bar(g) CSA: 16 bar(g) CSA: 16 bar(g) PN25 device flange (optional) ATEX/IECE: 20 bar(g) CL300 device flange (optional) ATEX/IECE: 20 bar(g) CSA: 16 bar(g) ATEX/IECE: 20 bar(g) CSA: 16 bar(g) ************************************	Operating pressure ¹	
 SA: 16 bar(g) ATEX/IECEx: 20 bar(g) CL300 device flange (optional) ATEX/IECEX: 20 bar(g) CSA: 16 bar(g) ATEX/IECEX: 20 bar(g) CSA: 16 bar(g) ¹remperature dependent. For details, see section Application ranges. Ex-approvals Ex-db [ia Ga] IIA T4 Ga/Gb EX db [ia Ga] IIA T4 Ga/Gb I1/26 Ex db [ia Ga] IIC T6 Ga/Gb I1/20 Ex db [ia Ga]	CL150 device flange	ATEX/IECEx: 20 bar(g)
PN25 device flange (optional) ATEX/IECEX: 20 bar(g) CSA: 16 bar(g) CL300 device flange (optional) TEX/IECEX: 20 bar(g) CSA: 16 bar(g) **Temperature dependent. For details, see section Application ranges. Ex-approvals Ext b(ia Ga) IIA T4 Ga/Gb Ex db (ia Ga) IIB T4 Ga/Gb Ex db (ia Ga) IIB T4 Ga/Gb Ex db (ia Ga) IIB T4 Ga/Gb II 1/2G Ex db (ia Ga) IIB T4 Ga/Gb NEC/CEC (US/CA) Class I, Division 1, Group D, T4; Class I, Zone 2, Ex/AEx Af(ia) IIA, T4; Class I, Zone 2, Ex/AEx Af(ia) IIA, T4; Class I, Zone 2, Ex/AEx Af(ia) IIB, T4; Class I, Zone 2		CSA: 16 bar(g)
CL300 device flange (optional) CSA: 16 bar(g) ATEX/IECEX: 20 bar(g) *Temperature dependent. For details, see section Application ranges. Ex-approvals EX-approvals ICEX Ex db [ia Ga] IIA T4 Ga/Gb Ex db [ia Ga] IIC T6 Ga/Gb Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIB T4 Ga/Gb Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2 C Ex db [ia Ga] IIC T6 Ga/Gb I 1/2 C Ex db [ia Ga] IIC T6 Ga/Gb I 1/2 C Ex db [ia Ga] IIC T6 Ga/Gb I 1/2 C Ex db [ia Ga] IIC T6 Ga/Gb I 1/2 C Ex db [ia Ga] IIC T6 Ga/Gb I 1/2 C Ex db [ia Ga] IIC T6 Ga/Gb I 1/2 C Ex db [ia Ga] IIC T6 Ga/Gb <th>PN25 device flange (optional)</th> <th>ATEX/IECEx: 20 bar(g)</th>	PN25 device flange (optional)	ATEX/IECEx: 20 bar(g)
CL300 device flange (optional) ATEX/IECEx: 20 bar(g) 'Temperature dependent. For details, see section Application ranges. Ex-approvals Ex db [ia Ga] IIA T4 Ga/Gb Ex db [ia Ga] IIB T4 Ga/Gb Ex db [ia Ga] IIB T4 Ga/Gb Ex db [ia Ga] IIC T6 Ga/Gb II 1/2G Ex db [ia Ga] IIB T4 Ga/Gb II 1/2G Ex db [ia Ga] IIB T4 Ga/Gb II 1/2G Ex db [ia Ga] IIB T4 Ga/Gb II 1/2G Ex db [ia Ga] IIC T6 Ga/Gb II 1/2G Ex db [ia Ga] IIB T4 Ga/Gb II 1/2G Ex db [ia Ga] IIB T4 Ga/Gb II 1/2G Ex db [ia Ga] IIB T4 Ga/Gb II 1/2G Ex db [ia Ga] IIC T6 Ga/Cb Class I, Division 1, Group D, T4; Class I, Division 1, Group D, T4; Class I, Division 2, Group D, T4; Class I, Division 1, Groups C and D, T4; Class I, Division 1, Groups C and D, T4; Class I, Division 1, Groups B, C and D, T4; Class I, Division 1, Groups B, C and D, T4; Class I, Division 1, Groups B, C and D, T4; Class I, Division 1, Groups B, C and D, T4; Class I, Division 1, Groups B, C and D, T4; Class I, Division 1, Groups B, C and D, T4; Class I, Division 1, Groups A, B, C and D, T4; Class I, Division 2, Groups A, B, C and D, T4; Class I, Division 2, Groups A, B, C and D, T4; Class I, Division 2, Groups A, B, C and D, T4; Class I, Division 2, Groups A, B, C and D, T4; Class I, Division 2, Grou		CSA: 16 bar(g)
Ex-approvalsCSA: 16 bar(g)Ex-approvals"Temperature dependent. For details, see section Application ranges.Ex-approvalsEcctaECEXEx db [ia Ga] IIA T4 Ga/Gb Ex db [ia Ga] IIB T4 Ga/Gb II 1/2G Ex db [ia Ga] IIB T4 Ga/GbATEXII 1/2G Ex db [ia Ga] IIB T4 Ga/Gb II 1/2G Ex db [ia Ga] IIC T6 Ga/GbNEC/CEC (US/CA)Class I, Division 1, Group D, T4; Class I, Division 2, Group D, T4; Class I, Division 2, Group D, T4; Class I, Division 2, Group C and D, T4; Class I, Division 2, Group S C and D, T4; Class I, Division 2, Group S C and D, T4; Class I, Division 1, Group S B, C and D, T4; Class I, Division 2, Group S, C and D, T4; Class I, Division 2, Group S, C and D, T4; Class I, Division 2, Group S, C and D, T4; Class I, Division 2, Group S, C and D, T4; Class I, Division 2, Group S, C and D, T4; Class I, Division 2, Group S, B, C and D, T4; Class I, Division 2, Group S, B, C and D, T4; Class I, Jone 2, Ex/AEx nA[ia] IIB, T4Gas temperature-196 °C +280 °CWeight≤ 10 kg (pair of ultrasonic sensors)	CL300 device flange (optional)	ATEX/IECEx: 20 bar(g)
Image: Instant of the image: Image		CSA: 16 bar(g)
Temperature dependent. For details, see section Application ranges. Ex-approvals IECEx Ex db [ia Ga] IIA T4 Ga/Gb Ex db [ia Ga] IIB T4 Ga/Gb Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIA T4 Ga/Gb I 1/2G Ex db [ia Ga] IIB T4 Ga/Gb I 1/2G Ex db [ia Ga] IIB T4 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 1/2G Ex db [ia Ga] IIC T6 Ga/Gb I 16 Cas I, Division 1, Group D, T4; Class I, Zone 2, Ex/AEx nA[ia] IIA, T4 Class I, Division 2, Groups C and D, T4; Class I, Zone 2, Ex/AEx nA[ia] IIB, T4 Class I, Division 2, Groups A, B, C and D, T4; Class I, Division 2, Groups A, B, C and D, T4; Class I, Division 2, Groups A, B,		
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IECExEx db [ia Ga] IIA T4 Ga/Gb Ex db [ia Ga] IIB T4 Ga/Gb Ex db [ia Ga] IIC T6 Ga/GbATEXII 1/2G Ex db [ia Ga] IIC T6 Ga/GbNEC/CEC (US/CA)Class I, Division 1, Group D, T4; Class I, Zone 1, Ex/AEx d[ia] IIA, T4; Class I, Zone 2, Ex/AEx nA[ia] IIA, T4; Class I, Division 1, Group D, T4; Class I, Division 1, Group D, T4; Class I, Division 1, Group D, T4; Class I, Division 2, Group D, T4; Class I, Division 2, Group D, T4; Class I, Division 1, Groups C and D, T4; Class I, Division 1, Groups C and D, T4; Class I, Zone 1, Ex/AEx d[ia] IIB, T4; Class I, Zone 1, Ex/AEx d[ia] IIB, T4; Class I, Division 1, Groups C and D, T4; Class I, Zone 2, Ex/AEx nA[ia] IIB, T4; Class I, Zone 2, Ex/AEx nA[ia] IIC, T4Gas temperature-196 °C +280 °CWeight\$ 10 kg (pair of ultrasonic sensors)	Ex-approvals	
Ex db [ia Ga] IIB 14 Ga/GbEx db [ia Ga] IIC 16 Ga/GbATEXII 1/2G Ex db [ia Ga] IIC 16 Ga/GbII 1/2G Ex db [ia Ga] IIC 16 Ga/GbII 1/2G Ex db [ia Ga] IIC 16 Ga/GbNEC/CEC (US/CA)Class I, Division 1, Group D, T4;Class I, Division 2, Group D, T4;Class I, Division 2, Group D, T4;Class I, Division 1, Group D, T4;Class I, Division 1, Group D, T4;Class I, Division 2, Group D, T4;Class I, Division 1, Group C and D, T4;Class I, Division 1, Groups C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Zone 2, Ex/AEx nA[ia] IIB, T4Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B,	IECEx	Ex db [ia Ga] IIA T4 Ga/Gb
Ex db [ia Ga] IIC 16 Ga/GbATEXII 1/2G Ex db [ia Ga] IIA 14 Ga/GbII 1/2G Ex db [ia Ga] IIB 14 Ga/GbII 1/2G Ex db [ia Ga] IIB 16 Ga/GbNEC/CEC (US/CA)Class I, Division 1, Group D, T4;Class I, Division 2, Group D, T4;Class I, Division 1, Group C, and D, T4;Class I, Division 1, Groups C and D, T4;Class I, Division 2, Groups C and D, T4;Class I, Division 1, Groups B, C and D, T4;Class I, Division 1, Groups B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Division 2, Groups A, B, C and D, T4;Class I, Zone 2, Ex/AEx nA[ia] IIC, T4Gas temperature<196 °C +280 °CWeight<10 kg (pair of ultrasonic sensors)		Ex db [ia Ga] IIB T4 Ga/Gb
AlEXII 1/2G EX db [ia Ga] IIA 14 Ga/GbII 1/2G EX db [ia Ga] IIB T4 Ga/GbII 1/2G EX db [ia Ga] IIC T6 Ga/GbNEC/CEC (US/CA)Class I, Division 1, Group D, T4; Class I, Zone 2, Ex/AEx d[ia] IIA, T4; Class I, Division 2, Group D, T4; Class I, Division 1, Group C and D, T4; Class I, Division 1, Group S C and D, T4; Class I, Division 2, Group S C and D, T4; Class I, Division 1, Group S C and D, T4; Class I, Division 2, Group S C and D, T4; Class I, Division 1, Group S C and D, T4; Class I, Division 1, Group S C and D, T4; Class I, Division 1, Group S C and D, T4; Class I, Division 1, Group S C and D, T4; Class I, Division 1, Group B, C and D, T4; Class I, Division 1, Group B, C and D, T4; Class I, Division 2, Group S A, B, C and D, T4; Class I, Division 2, Group S A, B, C and D, T4; Class I, Division 2, Group S A, B, C and D, T4; Class I, Division 2, Group S A, B, C and D, T4; Class I, Division 2, Group S A, B, C and D, T4; Class I, Zone 2, Ex/AEx nA[ia] IIB + H2, T4; Class I, Division 2, Group S A, B, C and D, T4; Class I, Zone 2, Ex/AEx nA[ia] IIB, T4Gas temperature-196 °C +280 °CWeight≤ 10 kg (pair of ultrasonic sensors)		
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NEC/CEC (US/CA)Class I, Division 1, Group D, T4; Class I, Zone 1, Ex/AEx d[ia] IIA, T4; Class I, Division 2, Group D, T4; Class I, Division 2, Group D, T4; Class I, Division 1, Groups C and D, T4; Class I, Division 1, Groups C and D, T4; Class I, Division 2, Group C and D, T4; Class I, Division 2, Groups C and D, T4; Class I, Division 1, Groups B, C and D, T4; Class I, Division 1, Groups B, C and D, T4; Class I, Division 1, Groups A, B, C and D, T4; Class I, Division 2, Groups A, B, C and D, T4; Class I, Zone 2, Ex/AEx nA[ia] IIB + H2, T4; Class I, Division 2, Groups A, B, C and D, T4; Class I, Zone 2, Ex/AEx nA[ia] IIC, T4Gas temperature-196 °C +280 °CWeight≤ 10 kg (pair of ultrasonic sensors)		
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Glass I, Division 2, Group D, T4; Class I, Division 2, Group D, T4; Class I, Division 1, Groups C and D, T4; Class I, Division 1, Groups C and D, T4; Class I, Division 2, Groups C and D, T4; Class I, Division 1, Groups B, C and D, T4; Class I, Division 1, Groups B, C and D, T4; Class I, Division 1, Groups A, B, C and D, T4; Class I, Division 2, Groups A, B, C and D, T4; Class I	NEC/CEC (US/CA)	Class I, Zone 1, Ev /AEv díja) IIA, TA:
Gas temperature-196 °C +280 °CWeight< 10 kg (pair of ultrasonic sensors)		Class I, Division 2, Group D, T4:
Class I, Division 1, Groups C and D, T4; Class I, Zone 1, Ex/AEx d[ia] IIB, T4; Class I, Division 2, Groups C and D, T4; Class I, Division 2, Groups C and D, T4; Class I, Zone 2, Ex/AEx nA[ia] IIB, T4 Class I, Zone 2, Ex/AEx nA[ia] IIB + H2, T4; Class I, Division 2, Groups A, B, C and D, T4; Class I, Zone 2, Ex/AEx nA[ia] IIC, T4Gas temperature-196 °C +280 °CWeight≤ 10 kg (pair of ultrasonic sensors)		Class I. Zone 2. Ex/AEx nAlial IIA. T4
Class I, Zone 1, Ex/AEx d[ia] IIB, T4; Class I, Division 2, Groups C and D, T4; Class I, Zone 2, Ex/AEx nA[ia] IIB, T4 Class I, Zone 2, Ex/AEx nA[ia] IIB, T4 Class I, Division 1, Groups B, C and D, T4; Class I, Zone 1, Ex/AEx d[ia] IIB + H2, T4; Class I, Zone 1, Ex/AEx nA[ia] IIC, T4Gas temperature-196 °C +280 °CWeight≤ 10 kg (pair of ultrasonic sensors)		Class I, Division 1, Groups C and D, T4:
Class I, Division 2, Groups C and D, T4; Class I, Zone 2, Ex/AEx nA[ia] IIB, T4 Class I, Division 1, Groups B, C and D, T4; Class I, Division 1, Groups B, C and D, T4; Class I, Zone 1, Ex/AEx d[ia] IIB + H2, T4; Class I, Division 2, Groups A, B, C and D, T4; Class I, Zone 2, Ex/AEx nA[ia] IIC, T4Gas temperature-196 °C +280 °CWeight≤ 10 kg (pair of ultrasonic sensors)		Class I, Zone 1, Ex/AEx d[ia] IIB, T4;
Class I, Zone 2, Ex/AEx nA[ia] IIB, T4Class I, Division 1, Groups B, C and D, T4; Class I, Zone 1, Ex/AEx d[ia] IIB + H2, T4; Class I, Division 2, Groups A, B, C and D, T4; Class I, Zone 2, Ex/AEx nA[ia] IIC, T4Gas temperature-196 °C +280 °CWeight≤ 10 kg (pair of ultrasonic sensors)		Class I, Division 2, Groups C and D, T4;
Class I, Division 1, Groups B, C and D, T4; Class I, Zone 1, Ex/AEx d[ia] IIB + H2, T4; Class I, Division 2, Groups A, B, C and D, T4; Class I, Zone 2, Ex/AEx nA[ia] IIC, T4 Gas temperature -196 °C +280 °C Weight ≤ 10 kg (pair of ultrasonic sensors)		Class I, Zone 2, Ex/AEx nA[ia] IIB, T4
Class I, Zone 1, Ex/AEx d[ia] IIB + H2, T4; Class I, Division 2, Groups A, B, C and D, T4; Class I, Zone 2, Ex/AEx nA[ia] IIC, T4 -196 °C +280 °C Weight ≤ 10 kg (pair of ultrasonic sensors)		Class I, Division 1, Groups B, C and D, T4;
Class I, Division 2, Groups A, B, C and D, T4; Class I, Zone 2, Ex/AEx nA[ia] IIC, T4 Gas temperature -196 °C +280 °C Weight ≤ 10 kg (pair of ultrasonic sensors)		Class I, Zone 1, Ex/AEx d[ia] IIB + H2, T4;
Class I, Zone 2, Ex/AEx nA[ia] IIC, T4 Gas temperature -196 °C +280 °C Weight ≤ 10 kg (pair of ultrasonic sensors)		Class I, Division 2, Groups A, B, C and D, T4;
Gas temperature -196 °C +280 °C Weight ≤ 10 kg (pair of ultrasonic sensors)		Class I, Zone 2, Ex/AEx nA[ia] IIC, T4
Weight ≤ 10 kg (pair of ultrasonic sensors)	Gas temperature	-196 °C +280 °C
	Weight	≤ 10 kg (pair of ultrasonic sensors)

Interface unit

Description	Unit for controlling the ultrasonic sensors and processing, evaluation and storage of measu- red value data
Ambient temperature	-40 °C +60 °C -40 °C +65 °C (optional (limited I/O))
Storage temperature	-40 °C +70 °C
Ambient pressure	80 kPa 110 kPa (0.8 bar 1.1 bar)
Ambient humidity	≤ 95 % Relative humidity
Ex-approvals	
IECEx (Zone 1)	Ex db eb ia IIC T4 Gb
ATEX (Zone 1)	EX do la lic 14 Go Il 2G Ex db eb ja lic T4 Gb
	II 2G Ex db ia IIC T4 Gb
CEC (CA) (Zone 1)	Ex d ia IIC T4 Gb
NEC (US) (Zone 1)	Class I, Zone 1, AEx d ia IIC T4 Gb
	Class I, Division 1, Groups B, C, D, 14
IECEx (Zone 2)	Ex ec ia IIC T4 Gc
ATEX (Zone 2)	II 3G Ex ec ia IIC T4 Gc
NEC/CEC (US/CA) (Zone 2)	Ex ec ia IIC T4 Gc Class L Zone 2: AEx ec ia IIC T4 Gc
	Class I Division 2, Group A, B, C and D, T4
Enclosure rating	IP66 acc. IEC 60529, Type 4X acc. UL50E
Analog outputs	Up to 6 outputs when using I/O modules (Option)
	16 bit:
	4 mA 20 mA
	In accordance with NAMUR NE43
	Passive, electrically insulated
	Reverse polarity protection
Analog inputs	Up to 6 inputs when using I/O modules (Option)
	4 mA 20 mA
	0 V 5 V DC
	In accordance with NAMUR NE43
	Passive, electrically insulated Reverse polarity protection
Digital outputs	Switching output:
с .	Up to 6 outputs when using I/O modules (Option)
	Electrically isolated
Max. Current	70 mA 50 Hz
Max. Input voltage	30 V DC
Max. Saturation voltage at output	0.5 V DC
	Switchable Namur/open collector
	Digital output / frequency output:
	Up to 12 digital outputs when using I/O modules (option)
Moy Current	Electrically isolated
Max. Switching frequency	10 kHz
Max. Input voltage	30 V DC
Max. Saturation voltage at output	1.8 V DC
	Reverse polarity protection

Digital inputs Min. input on voltage Max. input off voltage Max. clamping voltage	Up to 6 inputs with use of I/O modules (Option) Electrically isolated For connecting volt-free contacts or active switching outputs 2 V DC 2.85 V DC Max. clamping voltage 30 V DC Reverse voltage protection
Serial Type of fieldbus integration	 ✓ (3) RS-485 Electrically isolated
Ethernet Data transmission rate	✓ 10 Mbit/s 100 Mbit/s
Modbus Type of fieldbus integration	✓ TCP RTU RS-485 ASCII RS-485
HART [®] Type of fieldbus integration	✓ HART [®] master for connecting external pressure and temperature transmitter HART [®] slave (for communication with control system)
Foundation Fieldbus Comment Data transmission rate	 ✓ (Option) Clamping voltage: DC 9 V DC 32 V DC Current consumption: 18 mA FOUNDATION fieldbus™ H1, IEC 61158-2 with 31.25 kBit/s ITK 6.3 3 transducer blocks for process measurement variables, counter readings and diagnostic variables 8 Al blocks 1 PID block
Optical interface Type of fieldbus integration	✓ Service interface (IR, according to IEC 62056-21)
Indication	LCD: Measurands, system information, maintenance, need for maintenance, alarm
Operation	Software FLOWgate [™] or operating panel on the LCD
Dimensions (W x H x D)	For details see dimensional drawings
Weight Zone 1/Div 1 Ex db Ausführung Zone 1 Ex db eb Ausführung Non-Ex/Zone 2	17.5 kg 23 kg 8 kg
Electrical connection Voltage Frequency Power consumption	115 V AC 230 V AC $\pm 10\% / 15$ V DC 28 V DC AC variant: 50 Hz 60 Hz \leq 18 W (AC variant) / \leq 12 W (DC variant)
Options	Offshore version, sun and weather protection, tag plate, mounting set 2-inch-pipe installati- on, infrared-USB adapter, cable glands

Applications of FLOWSIC100 Flare-XT in regulated environment

The gas flow measuring instrument can be applied in emission measurements which may be subject to one or more regulations in some jurisdictions. Compliance with all emissions regulations applicable at the installation site remains owner / operator responsibility. If designed and applied correctly SICK's ultrasonic flow technology will meet or exceed most performance requirements set forth by any regulatory authority. Please contact your SICK representative to inquire about the correct flare measurement solution which will meet the currently applicable requirements set forth by the authorities.

Ordering information

Our regional sales organization will be glad to advise you on which device configuration is best for you.

Dimensional drawings (dimensions in mm)

Interface unit Cl. 1 Div. 2





Interface unit Zone 2





Interface unit Zone 1 EXDE





Interface unit CI.1 Div. 1 and Zone 1 EXD



F1F-S/H









Retracted position

Flare-XT Extended version Dimensions Α В С D Ε F G н 944 F1F-S 983 583 400 471 178 1055.5 871 F1F-H 846 448 398 919 518 178 851 917

Flare-XT Compact version	Dimensions								
	Α	В	С	D	E	F	G	Н	
F1F-S	883	583	300	771	471	178	955.5	844	
F1F-H	746	448	298	819	518	178	751.5	817	

F1F-P



Derating pressure resistance

F1F-S





F1F-P



Gas Application Evaluation Datasheet (exemplary presentation)

FLARE Gas Application Evaluation Datasheet FLOWSIC100 Flare / FLOWSIC100 Flare-XT **General Information Customer Data** OI Project Project Name Reference (CRM or SAP) For JB TAG Name or Number FT666 **Device Selection** Device Type F1F-S Nominal Pipe Width [inches] 12 Inner Diameter [inches] 12 Number of Paths 1 Installation Type Meter, SICK spool ² EX Zone Zone IIc ² Flare gas meter, measured spool piece from SICK with sensor integration and testing at factory site. **Order Reference** PO Number SICK Part Number SICK Serial Number **Process Data** Calculation basis: User-provided Parameters min norm max Pressure [bar] 1 1.5 1 Temperature [°C] 20 80 0 Speed of Sound [m/s] 300 410 600

Computed Results

Calculated Flow Ranges

	min	norm	max
Max velocity Vmax [m/s]	77.8	115.6	120
Max flow rate Qmax [m³/h]	20,425	30,369	31,521

Measurement Uncertainties

VoG [m/s]	Flowrate [m ³ /h]	Measurement Uncertainty of Flow (2ơ) [%]			
		min	norm	max	
0.03	7.9	6	11.1	23.6	
0.1	26.3	2.2	3.6	7.2	
0.3	78.8	1.4	1.8	2.7	
1	262.7	1.3	1.5	1.5	
3	788	1.3	1.4	1.4	
10	2,626.8	1.3	1.4	1.3	
Vmax	Qmax	1.3	1.4	1.3	

¹ For fully developed flow profiles; based on ultrasonic transit time measurement.

Uncertainty Chart for OI Project



Software-Version

Frontend: 1.5.2, Backend: 0.5.10

Disclaimer

The application evaluation sheet is electronically valid without signature. It is valid for Flare gas applications in compliance with the requirements stated in the latest version of the operating instructions.

Increased uncertainty may apply in case of transducer pair replacement.

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